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Honorable Commissioner for Patents Transmission via Facsimile: Total 3 pgs
Alexandria, VA 22313 (incl. cover sheet)

Attention: Le, Dung Anh
Group 2818 - Facsimile No. 571-273-8300

Re: T. OHYANAGI, et al - Serial No. 09/964,809
Attorney Docket No. 500.40681X00

STATEMENT OF SUMMARY OF INTERVIEW

Sir:

Applicant hereby submits the attached paper entitled, STATEMENT OF SUMMARY OF INTERVIEW (2 pgs) in the above-identified application.

CERTIFICATE OF TRANSMISSION:

I hereby certify that the attached paper Statement of Summary of Interview, is being formally filed in the USPTO via Facimile No. 571-273-8300 on April 14, 2006.


Greg Boylan

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APR 14 2006

500.40681X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: T. OHYANAGI, et al.
Application No.: 09/964,809
Filed: September 28, 2001
For: FIELD EFFECT TRANSISTOR AND SEMICONDUCTOR
DEVICE MANUFACTURING METHOD
Art Unit: 2818
Examiner: Le, Dung Anh

STATEMENT OF SUMMARY OF INTERVIEW

Mail Stop: AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 14, 2006

Sir:

Appreciation is expressed to Examiner Le Dung for his courtesy and helpfulness during a telephone interview conducted in the above-identified matter on April 13, 2006. During the course of this telephone interview, Examiner Dung indicated that he had received the Information Disclosure Statement (IDS) filed on February 14, 2006, following the mailing of the Notice of Allowance on February 10, 2006. Examiner Dung further indicated that, since the IDS had been filed within three (3) months of the mailing date of the Office Action in the Japanese Patent Office, and since no previous Office Action on the Merits had been mailed in the present U.S. application, he would proceed to consider the IDS filed on February 14, 2006. Examiner Dung also indicated that he would

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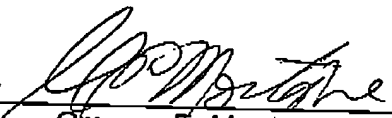
charge the necessary fees for considering this IDS, due to its having been filed following a Notice of Allowance, to the deposit account of the undersigned attorney.

Applicants and the undersigned attorney express their sincere appreciation to Examiner Dung for his indication that the IDS would be considered.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to the Antonelli, Terry, Stout & Kraus, LLP Deposit Account No. 01-2135 (Docket No. 50040681X00), and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

By 
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GEM/gjb